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INFORM	INFORMATION DISCLOSURE STATEMENT BY APPLICANT				May 11, 2001	
STATEME					STAHLER et al.	
					1639	
				Examiner Name	Bennett M. Celsa	
				Confirmation No.	3624	
Sheet	1	of	3	Attorney Docket Number	2923-438	

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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁴Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Filing Date	May 11, 2001	
				First Named Inventor	STAHLER et al.	
				Group Art Unit	1639	
				Examiner Name	Bennett M. Celsa	
				Confirmation No.	3624	
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				Confirmation No.	3624	
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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T²
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